

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/829,621	LUICK, DAVID ARNOLD	
Examiner		Art Unit		Page 1 of 1
Daniel Kim		2185		

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0088489	05-2004	Hironaka et al.	711/131
*	B	US-2002/0152368	10-2002	Nakamura, Tomohiro	712/226
*	C	US-2004/0210749	10-2004	Biles, Stuart David	712/240
*	D	US-2005/0262332	11-2005	Rappoport et al.	712/239
*	E	US-6,629,268	09-2003	Arimilli et al.	714/42
*	F	US-2005/0182907	08-2005	Shen et al.	711/146
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.